

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

Database System with Methodology for Parallel Schedule
Generation in a Query Optimizer

Application Number : 10/711931



Confirmation Number: 5930

First Named Applicant: Sudipto Chowdhuri

Attorney Docket Number: SYB/0114.00

Art Unit: 2167

Examiner: John E Breene

Search string: (6910032 or 6732084 or 6691101 or 6625593 or 6594651 or 6564205 or 6510428 or 6507834 or 6289334 or 6263328 or 6192359 or 6112198 or 6101495 or 6026394 or 6009265 or 5940289 or 5926809 or 5884303 or 5806059 or 5692174 or 5590319 or 5574900 or 5412804 or 4870568),pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6910032	2005-06-21	Carlson et al.		707	3
	2	6732084	2004-05-04	Kabra et al.		707	2
	3	6691101	2004-02-10	MacNicol et al.		707	2
	4	6625593	2003-09-23	Leung et al.		707	2
	5	6594651	2003-07-15	Kabra et al.		707	2
	6	6564205	2003-05-13	Iwata et al.		707	2
	7	6510428	2003-01-21	Tsuchida et al.		707	6
	8	6507834	2003-01-14	Kabra et al.		707	2
	9	6289334	2001-09-11	Reiner et al.		707	3
	10	6263328	2001-07-17	Coden et al.		707	3
	11	6192359	2001-02-20	Tsuchida et al.		707	4
	12	6112198	2000-08-29	Lohman et al.		707	3
	13	6101495	2000-08-08	Tsuchida et al.		707	4
	14	6026394	2000-02-15	Tsuchida et al.		707	3
	15	6009265	1999-12-28	Huang et al.		707	3
	16	5940289	1999-08-17	Iwata et al.		700	2
	17	5926809	1999-07-20	Szalwinski		707	3
	18	5884303	1999-03-16	Brown		707	3
	19	5806059	1998-09-08	Tsuchida et al.		707	2
	20	5692174	1997-11-25	Bireley et al.		707	3
	21	5590319	1996-12-31	Cohen et al.		707	4

	22	5574900	1996-11-12	Huang et al.		707	1
	23	5412804	1995-05-02	Krishna		707	2
	24	4870568	1989-09-26	Kahle et al.		707	5

Remarks

Note: Remarks are not for responding to an office action.

This statement is not intended to represent that a search has been made or that the information cited in the statement is, or is considered to be, material to patentability as defined in Sec. 1.56.

Signature

Examiner Name	Date